Invited Lectures of Overseas Researchers

Date	Hours	Room	Title	Speaker
9/13 (Sun.)	8. Plasma Electronics			
	13:00-13:45	1F	Evolution of Electron Density and Temperature in the Afterglow of Low Pressure Argon Discharges	Yi-Kang Pu (Tsinghua Univ.)
	8. Plasma Electronics			
	13:45-14:30	1F	Integrated Approaches for Surface Chemistry Control in Plasma Processing	Peter L. G. Ventzek (Tokyo Electron America Inc.)
9/15 (Tue.)	6. Thin Films and Surfaces			
	9:00-9:45	2J	Development of MgB_2 composites by spark plasma sintering as a superconductor and as a novel material for biomedical applications	Petre Badica (National Inst. of Materials Physics)